

MAR 28 2007


## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein  
Application Serial No.: 10/649,910  
Filing Date: 26 August 2003  
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER SYSTEM  
Examiner: Shay, David M.  
Art Unit: 3735  
Atty. Docket No.: 072287-0019  
Confirmation No.: 5770

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**CERTIFICATE OF MAILING OR TRANSMISSION**

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Date: 3/28/07  
Erin Olson

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT - ELECTION WITH TRAVERSE**

This paper is in response to the Office Action dated 29 December 2006, with included restriction requirement, for the above-identified application.

The Applicant requests that subject application be amended in accordance with the following:

- **Amendments to the Claims**, as listed in the listing of claims beginning on page 2 of this paper; and
- **Remarks**, beginning on page 6 of this paper.

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